



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tuschel et al.

: Group Art Unit: 2877

:
:

Serial No.: 10/610,481

: Examiner: Layla Lauchman

:
:

Filed: June 30, 2003

: Attorney Docket No.: 030354

For: METHOD FOR RAMAN IMAGING :
OF SEMICONDUCTOR :
MATERIALS :

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action dated November 22, 2005, the Applicants submit the following remarks and amendments.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Name Sharon B. McCullen

Signature

Sharon B. McCullen

Date of Deposit March 10, 2006